



PATENT  
Atty. Dkt. No. AMAT/5617.Y1/CMP/CMP/RKK

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:  
Hsu, et al.

**Serial No.:** 09/939,323

**Confirmation No.: 3877**

Filed: August 24, 2001

For: Method for Dishing Reduction  
and Feature Passivation in  
Polishing Processes

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

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Group Art Unit: 1765

Examiner: Robert M. Kunemund

<b>CERTIFICATE OF MAILING</b> <b>37 CFR 1.8</b>	
<p>I hereby certify that this correspondence is being deposited on  <u>September 7, 2004</u>, with the United States Postal Service as  First Class Mail in an envelope addressed to: Mail Stop  Amendment, Commissioner for Patents, P.O. Box 1450,  Alexandria, VA 22313-1450.</p>	
<u>September 7, 2004</u>	
Date	Signature

## **RESPONSE TO OFFICE ACTION DATED MAY 5, 2004**

In response to the Office Action dated May 5, 2004, having a shortened statutory period for response extended one-month to expire on September 7, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5617.Y1/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 8 of this paper.